

Notice of References Cited	Application/Control No. 10/553,309		Applicant(s)/Patent Under Reexamination GRUMMON, DAVID S.	
	Examiner MARINA TIETJEN		Art Unit 3753	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,619,177 A	04-1997	Johnson et al.	337/140
*	B	US-5,836,066 A	11-1998	Ingram, Richard B.	29/90.7
*	C	US-2002/0007958 A1	01-2002	Rivelli et al.	174/102.00R
*	D	US-2002/0112788 A1	08-2002	Tanaka et al.	148/402
*	E	US-2003/0020502 A1	01-2003	Sugihara et al.	324/754
*	F	US-2003/0074503 A1	04-2003	Echartea et al.	710/104
*	G	US-2003/0062254 A1	04-2003	Choi et al.	204/192.3
*	H	US-6,655,011 B1	12-2003	Kornrumpf et al.	29/622
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U	Krullevitch et al., Thin Film Shape Memory Alloy Microactuators, 1996, Journal of Microelectromechanical Systems, Vol. 5, No. 4, Pgs. 270-281			
	V				
	W				
	X				

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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